MAN 2 6 2005

JN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	
Filing Date	
Inventor	David R. Hembree
Assignee	Micron Technology, Inc.
Group Art Unit	
Examiner	V. Nguyen
Attorney's Docket No	MI22-1684
Title: Methods of Processing a Workpiece, Methods of Respect to a Wafer, and Methods of Communicating Processing Apparatus	0 0

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

ated: 5/25/05 Attorney:

Respectfully submitted,

James D. Shaurette Reg. No. 39,833

EV549570253

			NT OF COMMERCE ADEMARK OFFICE	ATTY, DOCKET NO. MI22-1684.			SERIAL NO. 09/827,248			
LIST OF ART CITED BY APPLICANT					APPLICANT: David R. Hembree					
MAY 1			FILING DATE April 4, 2001			GROUP 2829				
- CO	U.S. PATENT DOCUMENTS HILING DATE April 4, 2001 2829									
*Examiner Initial			Document Number	Date	Name	:	Class	Subo	class	Filing Date If Appropriate
		AA	5,703,287	12/1997	Treutler et al.			•		
		AB	5,945,834	8/1999	Nakata et al.					
		AC	5,478,242	12/1995	Walker et al.					
		AD	5,830,372	11/1998	Hierold					
		AE								
		AF				·				
		AG								
		АН								
			OTHER REFI	ERENCES (incl	uding Author, Title, I	Date, Pertinent P	ages, Etc.)	-	
	ΑI						_			
	<u>AJ</u>									
					<u> </u>	1 A F.S		n ==		
	<u>A</u> <u>K</u>		EV54731U635							
	<u>v</u>									*
	<u>AL</u>									
EXAMINER DATE CONSID				DATE CONSIDI	DERED					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance										

IN THE NITED STATES PATENT AND TRADEMARK OFFICE Application Serial No. 09/827,248 Filing Date April 4, 2001 Inventor David R. Hembree Assignee Micron Technology, Inc. Group Art Unit 2829 Examiner V. Nguyen Attorney's Docket No. MI22-1684 Title: Methods of Processing Wafers and Methods of Communicating Signals With Respect to a Wafer

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

Dated: 2/16/05

Attorney:

Respectfully submitted,

James D. Shaurette Reg. No. 39,833

EV549568285

Form PTO-144	يع درسو		U.	S. DEPARTMENT OF COMMERCE	ATTY, DOCKET No.		SERIA	AĹ NO.	
			PA'	FENT AND TRADEMARK OFFICE	M122-1684 09/827,248				
TIST OF ART CITED BY APPL (Use several sheets if necessar				APPLICANT Micron Technology, Inc.					
\ ``` 5 /					FILING DATE April 4, 2001		GROU 2858	GROUP 2858	
FIE	Te TR	DE MARTIN		U.S. PATENT DOCUMENTS		-			
*Examiner Initial		Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate	
	АА	6,635,852	10/21/2003	Seiwa					
	AB	6,709,878	3/23/2004	Akram et al.					
	AC	6,645,701	11/11/2003	Ota et al.					
	AD								
	AE								
	AF								
	AG						·		
	AH								
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)									
	AI				 	 			
						•			
	٧ī		FURAORK8985						
	<u>AK</u>				·				
	ľ					 	,		
	矿								
. ,				···			<u> </u>		
EXAMINER DATE CONSIDERED									
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									